

402-391-4448

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#8/105

4-15-03

10328 PINEHURST AVE. OMAHA. NEBRASKA 68124

Hayes

March 14, 2003

Assistant Commissioner for Patents Patent & Trademark Office Washington, D.C. 20231

RE: OPPOSITION BY THIRD PARTY REGARDING PUBLISHED APPLICATION OF

EBERT ET AL. TITLED: "MULTIPLE BEAM ELLIPSOMETR";

PUB. NO. US2003/0030806 A1; PUB. DATE: FEB. 13, 2003;

SERIAL NO. 10/042,592; FILED: JAN. 9, 2002.

OPPOSITION TO PUBLISHED U.S. PATENT APPLICATION

Dear Sir;

Enclosed please find a check for \$180.00 and a Listing of Printed Materials, submitted under 37 C.F.R. 1.99,

PATENT NO. 5,872,630 TO JOHS ET AL.;

PATENT NO. 6,181,421 T ASPNES ET AL.;

PATENT NO. 5,091,320 TO ASPNES ET AL.;

PATENT NO. 4,653,924 TO ITONAGA ET AL.;

GERMAN PATENT NO. DE 42 19 691 A1.

ARTICLES

"IMPROVED ROTATING ANALYZER-POLARIZER TYPE OF SCANNING ELLIPSOMETER"; CHEN ET AL., THIN FILM SOLIDS, 234(1993).

"DESIGN OF A SCANNING ELLIPSOMETER BY SYNCHRONOUS ROTATION OF THE POLARIZER AND ANALYZER", CHEN ET AL, APPL. OPT. VOL. 33, NO. 7 (1994).

"NEW DESIGN OF THE VARIABLE ANGLE INFRARED SPECTROSCOPIC ELLIPSOMETER USING DOUBLE FOURIER TRANSFORMS", XIA ET AL., REV.

SCI. INSTRUM. VOL. 71, NO. 1, (2000).

"ROTATING-COMPENSATOR MULTICHANNEL ELLIPSOMETRY: APPLICATIONS FOR REAL TIME STOKES VECTOR SPECTROSCOPY OF THIN FILM GROWTH", LEE ET AL., REV. SCI. INSTRUM. VOL. 69, NO. 4, (1998).

"ROTATING-COMPENSATOR MULTICHANNEL ELLIPSOMETER FOR CHARACTERIZATION OF THE EVOLUTION OF NONUNIFORMITIES IN DIAMOND THIN-FILM GROWTH", APPL. PHYS. LETT., VOL. 72, NO. 8 (1998).

I hereby attest that Service was made on the Applicant's Attorney Michael Stallman, Stallman & Pollock LLP., Suite 290 121 Spear St., San Francisco, CA 94105, via United States First Class Mail sent March 14, 2003.

JAMES D. WELCH

JW/hs

Sincexelly,

énc. cc. Michael Stallman, Stallman & Pollock LLP.



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INTELLECTUAL PROPERTY 402-3 1-4448 10328 PINEHURST AVE. OMAHA, NEBRASKA 68124

March 14, 2003

Stallman & Pollock LLP.

ATTN: Michael Stallman

Suite 290

121 Spear St.

San Francisco, CA 94105

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Dear Sirs;

Enclosed are copies of materials we feel the Patent Office should consider in examination of the identified Application, and have submitted to the PTO.

JAMES D. WELCH

JW/hs enc.